

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as Express Mail, Airbill No. EV506674675US, in an envelope addressed to: MS AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: February 18, 2005

Signature:

(Marco Jimenez)



Docket No.: 514802002600
Client reference: AD-0371US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Mitsuyuki ASAKI et al.

Confirmation No.: 4476

Application No.: 10/664,440

Examiner: Johnnie L. Smith

Filed: September 18, 2003

Art Unit: 2881

For: PATTERN WIDTH MEASURING
APPARATUS, PATTERN WIDTH
MEASURING METHOD, AND ELECTRON
BEAM EXPOSURE APPARATUS

*RCE processed
4/21/05
Amw*

AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated November 18, 2004, for which a response is due on February 18, 2005, please amend the above-identified U.S. patent application as follows:

LA-772941